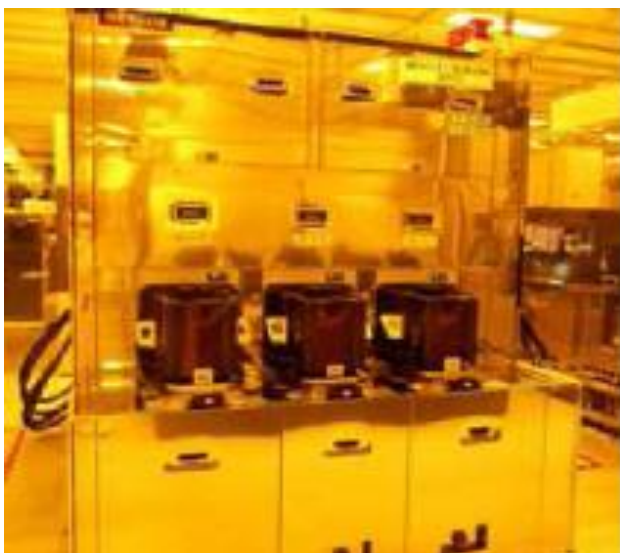


Tool Type	Track	Tool ID	ACT1244
OEM	Tokyo Electron Limited	Model	Clean Track ACT-12
S/N	E-140807	Vintage	2004.7
Docked	NIKON Type	Shutdown	2018.3
Wafer Size	300mm		
Configuration	1C2D, LtoR, Foup Cassette		
Warehouse	Yachimata-city, Chiba, Japan	Sales	Where is, As is
Conditions	Packed, Power inspection is impossible,		

<Photo>



1-1 FOU	1-0 CRA	2-24 LHP	2-30	2-14 LHP	3-4 WEE	
		2-23 PHP	2-29	2-13 LHP	3-0 IRA	3-5 EIS
1-2 FOU		2-22	2-28	2-12 LHP		
		2-21 PHP	2-27	2-11 LHP		
1-3 FOU		2-20 CWH	2-26	2-10		
		2-19 CPL		2-9 CPL		
		2-8	2-25	2-18		
		2-7 ADH		2-17 CPL		
1-4		2-6 TRS-L	2-0 PRA	2-16 TRS		
		2-5 TCP-L		2-15 CPL		
		2-3 DEV		2-4 DEV		3-3 SBU
		2-1 OOT		2-2		3-2 SBU
						3-1 THS



## 【Configuration】

### Main system

- 1) Main frame with system controller
- 2) Carrier station
  - Type: Four Cassette Type - 3 Cassette
  - Uni-cassette system
- 3) Coater unit
  - 6 dispense nozzle with temperature controlled lines for etch unit
  - RDS Pump (Millipore)
  - Rinse nozzle : back/ EBR / solvent bath for etch unit
  - Rinse system : 3 liter 2Tank Buffer tank system
  - Degassing system.
  - Programmable side rinse
    - for PR nozzle(1, 2, 3, 4, 5, 6) - 36 bottles(1 bottle/1nozzle) in machine for unit
    - for Thinner supply - CCSS
  - AMC Suck-back valve - Drain: Direct drain
- 4) Developer unit
  - H nozzle(1ea) for each unit
  - 1 stream nozzle for DI rinse and 2 points for back side rinse on each unit
  - Developer system : 3 liter 2Tank Buffer tank system
  - Developer supply: CCSS - Degassing system
  - Developer temperature control system - Drain: direct drain
- 5) I/F Wafer Stage Type : NIKON Type(SF13)
- 6) Adhesion Unit 1EA
  - 100% sealing closed chamber(Built-in hot plate)
  - HMDS tank with float sensor in system - HMDS supply : Local bottle
- 7) Low Temp Hot Plates (LHP) 5EA
- 8) Chill Plates (CPL) 4EA
- 9) Precision Chilling Hot Plates (CHP) 4EA
- 10) TCP Unit 1EA
- 11) TRS Unit 2EA
- 12) WEE (wafer edge exposure ) unit 1EA
  - UV Sensor : I-line
- 13) Chemical Cabinet : Solvent , HMDS , DEV Chemical Cabinet
- 14) Temperature&Humidity controller
  - Type: Shinwa Series (ESA-8)
- 15) TEMP Control Unit(TCU) 1EA
- 16) AC Power Box